

Notice of References Cited	Application/Control No. 10/643,912	Applicant(s)/Patent Under Reexamination PARK ET AL.	
	Examiner Chen-Wen Jiang	Art Unit 3744	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,297,392 A	03-1994	Takata et al.	62/160
	B	US-5,309,733 A	05-1994	Hayashida et al.	62/278
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 11083223 A	03-1999	Japan	MICHIHASHI et al.	F25B 13/00
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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